

Ultrafast and Low-power-consumption Membrane Lasers on Si with Integrated Optical Feedback

Nikolaos-Panteleimon Diamantopoulos, Suguru Yamaoka, Takuro Fujii, and Shinji Matsuo

Abstract

We developed energy-efficient membrane III-V distributed-reflector lasers on silicon-based substrates for ultrafast short-reach communication links and neuromorphic computing applications. By leveraging high-speed photon-photon interactions enabled by integrated optical feedback and a high-optical-confinement membrane structure, we demonstrated record-fast directly modulated laser bandwidths and spike-processing rates with ultralow operating energies. This is a step towards our goal of reducing the carbon footprint of information and communication technology and artificial intelligence hardware, while keeping pace with the increasing demand of processing speeds.

Keywords: integrated photonics, membrane lasers, neuromorphic photonics.

1. Introduction

The advent of modern artificial intelligence and machine learning (AI/ML) applications and cloud services have led to tremendous information and communication technology (ICT) growth, enabling unprecedented processing capabilities. However, as processing and datacenter communication speeds continue to increase, so do their power consumption and associated CO₂ (carbon dioxide) emissions [1, 2]. To support ultrahigh speeds but at reduced power consumption, we developed membrane distributed-reflector lasers with integrated optical feedback for energy-efficient photonics-electronics convergence within NTT's Innovative Optical and Wireless Network (IOWN) project [3, 4].

With our membrane lasers with integrated optical feedback on silicon dioxide/silicon (SiO₂/Si) substrates, we could achieve unprecedented directly modulated laser (DML) bandwidths of ~60 GHz [5, 6] and spike-processing rates (i.e., inter-spike rate) of 10 GHz [7, 8] with sub-pJ/bit and ~pJ/spike laser-operating energies (see Fig. 1). We also achieved the

world's fastest DML bandwidth of ~108 GHz by integrating our membrane distributed-reflector lasers with integrated optical feedback on silicon carbide (SiC) substrates [9–11].

2. Membrane distributed-reflector lasers with integrated optical feedback

Our membrane laser structure for lasers fabricated on SiO₂/Si substrates is based on a distributed-reflector longitudinal design that includes a middle uniform-distributed feedback (DFB) section sandwiched with an 80- μ m-long back distributed Bragg reflector (DBR) mirror (DBR-*r*) and 200- μ m-long front DBR mirror (DBR-*f*). In this structure, the DBR-*r* is used to filter one of the two DFB modes for single-mode operation [12], and the DBR-*f* is used to generate optical feedback and side-modes for enacting photon-photon dynamics [5, 6, 9–11] (see Fig. 2). Very low operating-power consumption was achieved with our heterogeneous membrane III-V on Si technology, which uses a thin-film (<350-nm thick) III-V layer on a low-refractive index SiO₂/Si substrate with a similar

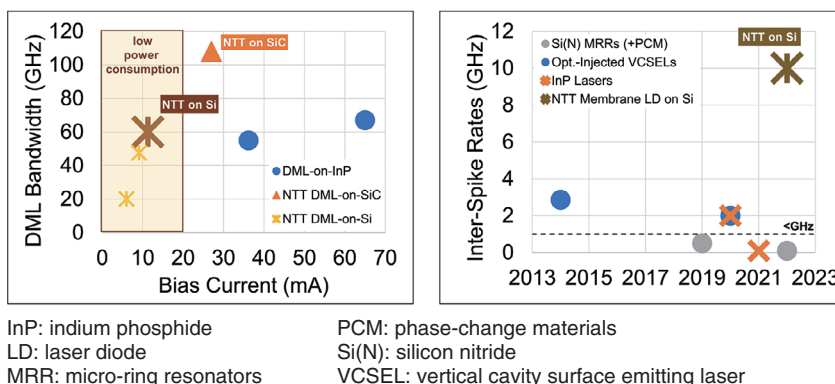


Fig. 1. Recent records of 3-dB bandwidths of DMLs [5, 6, 9–11] (left) and spike-processing rates of integrated photonic spiking neurons [7, 8] (right).

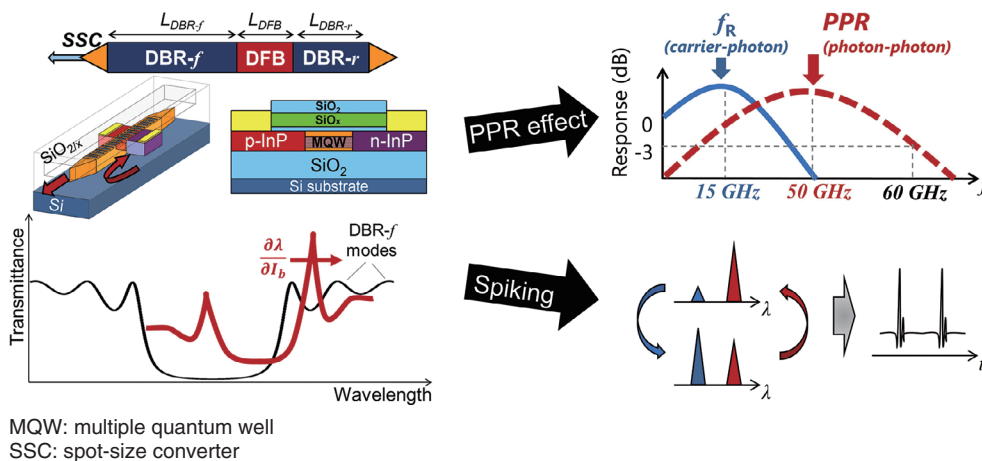


Fig. 2. Membrane distributed-reflector laser with integrated optical feedback [5–11].

low-refractive index SiO₂/silicon oxide (SiO_x) overladding. This structure enables very strong transverse optical confinement, which leads to both low operating power and high-speed dynamics. Other advantages include cost reduction by using large Si wafers and mature processes, co-integration capabilities with Si photonics and other integrated photonic platforms, and coupling to fibers via SiO_x-based spot-size converters.

3. Photon-photon resonance for short-reach communication links

Although our previously developed membrane DMLs could achieve high (~20 GHz) bandwidths with sub-pJ/bit energy consumptions [12], there is an

inherent trade-off between further DML bandwidth improvement and power consumption since the relaxation oscillation frequency (f_R) is proportional to the square-root of the bias current (I_b) above a threshold (I_{th}), i.e., $f_R \propto (I_b - I_{th})^{1/2}$. This limitation can be alleviated by introducing a photon-photon resonance (PPR) at high frequencies (see Fig. 2) on the basis of the optical-feedback-generated side-modes.

By using the PPR effect, we could effectively triple the bandwidths of the membrane DML-on-Si reaching ~60 GHz [5] while maintaining the same power consumption. This enabled us to achieve 112-Gbit/s short-reach transmissions for datacenter applications [5, 6] (see Fig. 3), and the first 400-Gbit/s-class link using a single >100-GHz-bandwidth DML-on-SiC [10]. We also demonstrated the ability to use the PPR

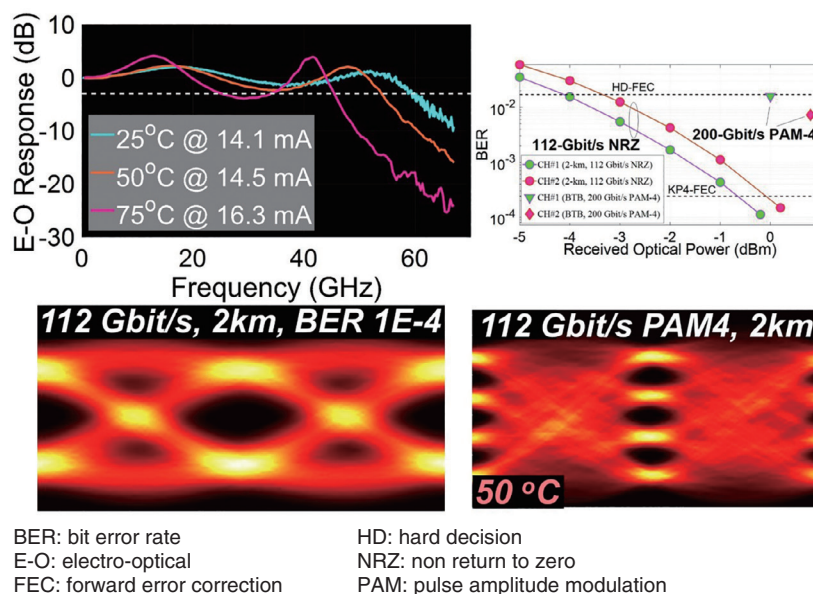


Fig. 3. Transmission performance of membrane DML-on-Si [5, 6].

effect at operating temperatures of 50°C and above, which enabled us to sustain >100-Gbit/s operation for short-reach links using a membrane DML-on-Si at 50°C [5, 6], and more than 100-GBaud modulations under uncooled (85°C) conditions using a membrane DML-on-SiC [11].

4. Spiking membrane laser neurons

One of the most promising neuromorphic computing architectures in terms of energy-efficiency and scalability is the hardware implementation of spiking neural networks (SNNs) due to the unmatched noise-tolerance and event-driven capabilities of spike-information processing. In particular, integrated photonics hold great promise in offering high-bandwidth and scalable on-chip SNNs by taking advantage of the tens-of-GHz speeds offered by modern opto-electronics and the numerous parallelization capabilities of photonics. Nevertheless, most photonic implementations of spiking neurons to date have been limited by physical processes that operate on nanosecond time scales or slower, leading to spike-processing rates (i.e., the factor that ultimately defines the processing speed) of around the GHz level or less.

By using our membrane laser structure with integrated optical feedback, we were able to demonstrate ultrafast spiking behavior with clearly defined thresh-

olds and spiking rates up to 10 GHz using 50-ps-long electrical pulses [7, 8] (see Fig. 4), overcoming previous speed limitations. This was achieved by taking advantage of the ultrafast photon-photon dynamics between two longitudinal modes (see Fig. 2). In such a case, a small input energy perturbation can temporarily excite a secondary longitudinal side-mode, which leads to power excitability of ultrashort (\sim ps long) output optical pulses, when the input energy perturbation exceeds an energy threshold. Moreover, our strong-confinement membrane-III-V-on-SiO₂/Si structure ensured very low operating and threshold energies of \sim pJ/spike and \sim 0.1 pJ/spike, respectively [7, 8].

5. Summary and future plans

To meet the increasing demands on processing speeds of modern ICT and AI applications, while maintaining low operating energies for a sustainable and greener future within the IOWN project, we developed ultrafast and energy-efficient membrane distributed-reflector lasers on Si-based substrates with integrated optical feedback. With such lasers, we could achieve unprecedented DML bandwidths of \sim 60 GHz and spike-processing rates of 10 GHz with \sim sub-pJ/bit and \sim pJ/spike, respectively.

Future developments will focus on multi-channel DML transmitters for 800-Gbit/s systems and beyond

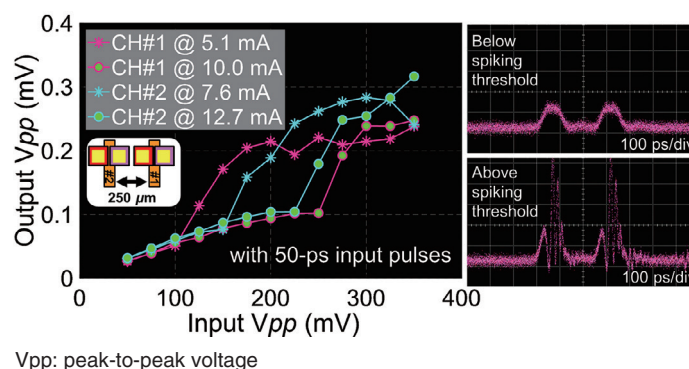


Fig. 4. Spiking effect in membrane lasers on Si [7, 8]. Note: oscilloscope data at ~240-ps inter-spike intervals are shown.

by taking advantage of our previously developed techniques and technologies [13, 14]. We also plan to expand our spiking-membrane laser technology to multi-neuron SNN-PICs (photonic integrated circuits) and showcase their capabilities at solving practical computational tasks at unprecedented processing speeds.

References

- [1] International Energy Agency (IEA), “Data Centres and Data Transmission Networks,” 2022. <https://www.iea.org/reports/data-centres-and-data-transmission-networks>
- [2] N. C. Thompson, K. Greenwald, K. Lee, and G. F. Manso, “Deep Learning’s Diminishing Returns: The Cost of Improvement Is Becoming Unsustainable,” *IEEE Spectrum*, Vol. 58, No. 10, pp. 50–55, 2021. <https://spectrum.ieee.org/deep-learning-computational-cost>
- [3] NTT Corporation, “NTT Technology Report for Smart World 2022,” 2022. https://www.rd.ntt/e/download/NTT_TRFSW_2022_E.pdf
- [4] T. Sakamoto, N. Sato, and T. Segawa, “Photonics-electronics Convergence Technologies for Disaggregated Computing,” *NTT Technical Review*, Vol. 19, No. 7, pp. 58–64, 2021. <https://www.ntt-review.jp/archive/ntttechnical.php?contents=ntr202107fa8.html>
- [5] N.-P. Diamantopoulos, T. Fujii, S. Yamaoka, H. Nishi, K. Takeda, T. Tsuchizawa, T. Segawa, T. Kakitsuka, and S. Matsuo, “60 GHz Bandwidth Directly Modulated Membrane III-V Lasers on SiO₂/Si,” *Journal of Lightwave Technology*, Vol. 40, No. 10, pp. 3299–3306, 2022. <https://doi.org/10.1109/JLT.2022.3153648>
- [6] N.-P. Diamantopoulos, S. Yamaoka, T. Fujii, H. Nishi, K. Takeda, T. Tsuchizawa, T. Kakitsuka, and S. Matsuo, “47.5 GHz Membrane-III-V-on-Si Directly Modulated Laser for Sub-pJ/bit 100-Gbps Transmission,” *Photonics*, Vol. 8, No. 2, Article no. 31, 2021. <https://doi.org/10.3390/photonics8020031>
- [7] N.-P. Diamantopoulos, S. Yamaoka, T. Fujii, H. Nishi, T. Segawa, and S. Matsuo, “Ultrafast Spiking Membrane III-V Laser Neuron on Si,” *Proc. of 2022 European Conference on Optical Communication (ECOC 2022)*, paper Mo3G.2, Basel, Switzerland, Sept. 2022. <https://opg.optica.org/abstract.cfm?uri=ECEOC-2022-Mo3G.2>
- [8] N.-P. Diamantopoulos, S. Yamaoka, T. Fujii, H. Nishi, T. Segawa, and S. Matsuo, “Stability of Spiking Effect in Membrane Laser Neurons on Si Utilizing Optical Feedback,” *Proc. of 28th International Semiconductor Laser Conference (ISLC 2022)*, paper WC-02, Matsue, Japan, Oct. 2022. <https://doi.org/10.23919/ISLC52947.2022.9943397>
- [9] S. Yamaoka, N.-P. Diamantopoulos, H. Nishi, R. Nakao, T. Fujii, K. Takeda, T. Hiraki, T. Tsurugaya, S. Kanazawa, H. Tanobe, T. Kakitsuka, T. Tsuchizawa, F. Koyama, and S. Matsuo, “Directly Modulated Membrane Lasers with 108GHz Bandwidth on a High-thermal-conductivity Silicon Carbide Substrate,” *Nature Photonics*, Vol. 15, pp. 28–35, 2021. <https://doi.org/10.1038/s41566-020-00700-y>
- [10] N.-P. Diamantopoulos, H. Yamazaki, S. Yamaoka, M. Nagatani, H. Nishi, H. Tanobe, R. Nakao, T. Fujii, K. Takeda, T. Kakitsuka, H. Wakita, M. Ida, H. Nosaka, F. Koyama, Y. Miyamoto, and S. Matsuo, “>100-GHz Bandwidth Directly-modulated Lasers and Adaptive Entropy Loading for Energy-efficient >300-Gbps/λ IM/DD Systems,” *Journal of Lightwave Technology*, Vol. 39, No. 3, pp. 771–778, 2021. <https://doi.org/10.1109/JLT.2020.3021727>
- [11] S. Yamaoka, N.-P. Diamantopoulos, H. Nishi, T. Fujii, K. Takeda, T. Hiraki, S. Kanazawa, T. Kakitsuka, and S. Matsuo, “Uncooled 100-Gbaud Directly Modulated Membrane Lasers on SiC Substrate,” *Journal of Lightwave Technology*, 2023. <https://doi.org/10.1109/JLT.2023.3239614>
- [12] T. Fujii, K. Takeda, N.-P. Diamantopoulos, E. Kanno, K. Hasebe, H. Nishi, R. Nakao, T. Kakitsuka, and S. Matsuo, “Heterogeneously Integrated Membrane Lasers on Si Substrate for Low Operating Energy Optical Links,” *IEEE Journal of Selected Topics in Quantum Electronics*, Vol. 24, No. 1, Article no. 1500408, 2018. <https://doi.org/10.1109/JSTQE.2017.2778510>
- [13] T. Fujii, K. Takeda, H. Nishi, N.-P. Diamantopoulos, T. Sato, T. Kakitsuka, T. Tsuchizawa, and S. Matsuo, “Multiwavelength Membrane Laser Array Using Selective Area Growth on Directly Bonded InP on SiO₂/Si,” *Optica*, Vol. 7, No. 7, pp. 838–846, 2020. <https://doi.org/10.1364/OPTICA.391700>
- [14] H. Nishi, T. Fujii, N.-P. Diamantopoulos, K. Takeda, E. Kanno, T. Kakitsuka, T. Tsuchizawa, H. Fukuda, and S. Matsuo, “Integration of Eight-channel Directly Modulated Membrane-laser Array and SiN AWG Multiplexer on Si,” *Journal of Lightwave Technology*, Vol. 37, No. 2, pp. 266–273, 2019. <https://doi.org/10.1109/JLT.2018.2873742>



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